25

30

35

09/600546 FR 009900043

534 Rec'd PCT/PTC 1 2 JUL 2000

CLAIMS

1. Writing process, in which said material is irradiated by means of a beam of light ions, such as He⁺ ions, having an energy of the order of or less than a hundred keV, characterized in that this material is a thin-layer material comprising buried layers deposited on a substrate, and in that one or more regions having sizes of the order of 1 micrometer or less are irradiated, the irradiation dose being controlled so as to be a few 10¹⁶ ions/cm² or less, the irradiation modifying the composition of atomic planes in the material at an interface between two layers of the latter.

- 15 2. Process according to plaim 1, characterized in that the irradiation is carried out through a mask.
 - 3. Process for the magnetic or magnetooptic recording of binary information, especially for the production of discrete magnetic materials, of magnetic
- 20 memory circuits or of magnetically-controllable logic circuits, characterized in that it employs a writing process according to one of the preceding claims.
 - 4. Optical recording process of the read-only memory type, characterized in that it employs a writing process according to either of claims 1 and 2.
 - 5. Process according to either of claims 5 and 6, characterized in that the recording material is a magnetic pultilayer material, the individual layers of which are pure metals or transition metal alloys or rare earth alloys.
 - 6. Process for producing magnetically-controllable optical circuits using a controlled variation of the optical index component associated with magnetism, characterized in that it employs a writing process according to either of claims 1 and 2.

Add

AMENDED SHEET